IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Docket No.: VLSI-2759.CPA Thereby certify that this transmittal of the below described document is being deposited with the United States Postal Service in an envelope bearing First Class Postage and addressed to the Assistant Commissioner for Patents, Washington, D.C., 20231, on the below date of deposit.

Date of 05/16/00 Name of Person KATHERINE RINALDI Signature of the Person Washington, D.C., 20231, on the below date of deposit. Deposit: Making the Deposit: Making the Deposit:



In re Application of:

Inventor(s): Charles Franklin Drill and Milind Weling

Application No.: 08/824,633

Filed: 03/27/97

Title: A CUSTOMIZED POLISHING PAD FOR SELECTIVE PROCESS PERFORMANCE DURING CHEMICAL MECHANICAL POLISHING

Assistant Commissioner for Patents Washington, D.C. 20231

CONDITIONAL PETITION FOR EXTENSION OF TIME

This conditional petition is being filed along with the

accompanying

DIVISIONAL and provides for the possibility that applicant has inadvertently overlooked the need for a petition and fee for extension of time.

Conditional petition for extension of time

If any extension of time for the accompanying response is required, applicant requests that this be considered a petition therefor.

Status

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This application is on behalf of	TEC T
X other than a small entity	養養的
a small entity	E 7 7
A verified statement:	10 P
is attached	S m
is already filed	2000 EELTE
[X] The Commissioner is hereby authorized to charge any additional fees associated communication or credit any overpayment to Deposit Account No.: 23-0085.	with this
A <u>duplicate copy</u> of this authorization is enclosed.	6

Page 1 of 2

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Please direct all correspondence concerning the above-identified application to the following address:

WAGNER, MURABITO & HAO LLP

Two North Market Street, Third Floor San Jose, California 95113 (408) 938-9060

Respectfully submitted,

Date: 1/2000

Glenn D. Barnes Reg. No. 42,293

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MAY 24 2000